

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-279001	Application No. 09/892,225
	Applicant Shunpei Yamazaki, et al.		
	Filing Date June 25, 2001	Group Art Unit 1722	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
MS	AA	5,932,893	08/03/1999	Miyanaaga et al.			02/03/1998
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	AD	6,087,679	07/11/2000	Yamazaki et al.			07/22/1998
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AW							
	AX							

Examiner Signature  /Matthew Song/	Date Considered  09/15/2006
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Foreign Patent Documents or Published Foreign Patent Applications								
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							Yes	No
	AY							
	AZ							
	AAA							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
MS	ABB	Haji et al., "Mode of Growth and Microstructure of Polycrystalline Silicon Obtained by Solid-Phase Crystallization of an Amorphous Silicon Film," J. Appl. Phys. 75 (8), April 15, 1994, pages 3944-3952.
MS	ACC	Hayzelden et al., "Silicide Formation and Silicide-Mediated Crystallization of Nickel-Implanted Amorphous Silicon Thin Films," J. Appl. Phys. 73 (12), June 15, 1993, pages 8279-8289.
	ADD	
	AEE	

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